



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT : Dong-Su Kim Atty. Docket No: 5000-1-212074-1
SERIAL NO. : 09/899,784 EXAMINER : Fernando Toledo
FILED : July 5, 2001 ART UNIT : 2823
FOR : METHOD OF FABRICATING SILICA MICROSTRUCTURES

Certificate of Mailing Under 37 CFR 1.8

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2002
9/25/02
(Signature and Date)

10/22/22
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TRANSMITTAL OF REVOCATION AND APPOINTMENT OF ATTORNEYS

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Dear Sir:

The undersigned, as an Applicant and owner hereof, hereby revokes all powers previously granted and appoints

Steve S. Cha

Registration No. 44,069

of CHA & REITER, 411 Hackensack Ave, 9th floor, Hackensack, New Jersey 07601, as new attorney with full power of substitution and revocation, to prosecute the above application, to make alterations and amendments therein, to receive the patent, and to transact all business in the Patent and Trademark Office connected herewith.

Please address any correspondence to

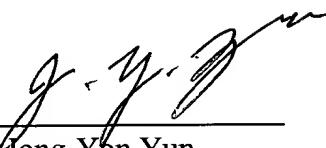
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and any telephone calls to Steve Cha, Esq., at (201) 518-5518.

Respectfully submitted,

Date: 9/10/02

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